



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: KIM et al.

Serial No.: 10/625,277

Title: SEMICONDUCTOR DEVICE
AND METHOD FOR
FABRICATING THE SAME

Filed: July 23, 2003

Art Unit: 2822

Examiner: Thanh Y. Tran

Docket Number: 29926/39495

Customer No.: 04743

-) I hereby certify that this paper and the documents referred to as enclosed therewith are being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on the date indicated: April 11, 2006.
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) 
) Aaron M. Peters
) Registration No. 48,801
) Attorney for Applicants

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop RCE
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, Virginia 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

A copy of the non-U.S. patent and non-U.S. published patent application documents on the PTO-1449 form is attached.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

TIME OF FILING

This information disclosure statement is being filed, to the best of the undersigned's knowledge, before the mailing date of a first Office action after the filing of a request for continued examination under 37 CFR §1.114. In accordance with 37 CFR §1.97(b), no certification or fee is required.

METHOD OF PAYMENT

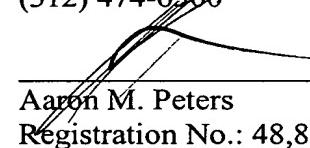
It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed reference.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 13-2855, under Order No. 29926/39495. A duplicate copy of this paper is enclosed.

Respectfully submitted,

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April 11, 2006

For PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 29926/39495	Serial No. 10/625,277
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT		Applicant KIM, et al.	
		Filing Date July 23, 2003	Group 2822



U.S. PATENT DOCUMENTS							
*Examiner Initials		Document Number	Issue Date	Name	Class	Subclass	Filing Date if Appropriate

U.S. PATENT APPLICATION PUBLICATIONS							
*Examiner Initials		Document Number	Publication Date	Name	Class	Subclass	Filing Date if Appropriate
		2002/0098654	07/25/2002	Durcan, et al.	438	267	02/22/2002

FOREIGN PATENT DOCUMENTS							
*Examiner Initials		Document Number	Publication Date	Country	Class	Subclass	Translation
							Yes No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
		Office Action for Chinese Application No. 200310116172.7 and English Translation thereof (6 pages).					

Examiner	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.